



*EFV*

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q78440

Takamitsu HIGUCHI, et al.

Appln. No.: 10/705,251

Group Art Unit: 2834

Confirmation No.: 3192

Examiner: Thomas M. DOUGHERTY

Filed: November 12, 2003

For: PIEZOELECTRIC DEVICE, LIQUID JETTING HEAD, FERROELECTRIC DEVICE,  
ELECTRONIC DEVICE AND METHODS FOR MANUFACTURING THESE DEVICES

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 14, 2006, please amend the above-identified application as follows on the accompanying pages.

**TABLE OF CONTENTS**

AMENDMENTS TO THE CLAIMS .....	2
REMARKS .....	29